



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 30, 2026

IGI Report Number

DESCRIPTION

SHAPE AND CUTTING STYLE

MEASUREMENTS

GRADING RESULTS

CARAT WEIGHT

COLOR GRADE

CLARITY GRADE

ADDITIONAL GRADING INFORMATION

POLISH

SYMMETRY

FLUORESCENCE

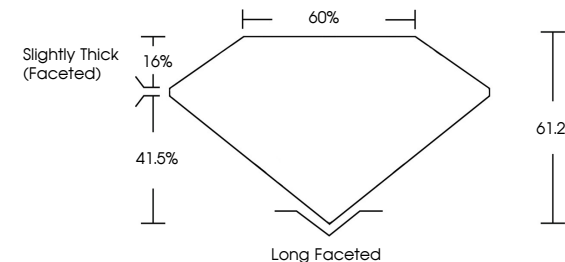
INSCRIPTION(S)

COMMENTS: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG818646006

Report verification at igi.org

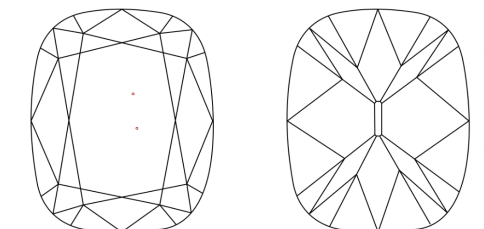
PROPORTIONS





Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

CLARITY

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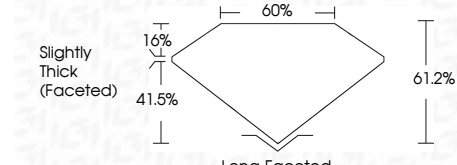
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COLOR

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IGI Report No LG818646006

ANTIQUE CUSHION CUT

9.12 X 6.00 X 3.67 MM

1.56 CARAT

VERY LIGHT BROWN

VS 1

EXCELLENT

EXCELLENT

VERY SLIGHT

IGI LG818646006

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IGI



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July 30, 2026

IGI Report No LG818646006

ANTIQUE CUSHION CUT

9.12 X 6.00 X 3.67 MM

1.56 CARAT

VERY LIGHT BROWN

VS 1

61.2%

60%

Slightly Thick (Faceted)

Long Faceted

EXCELLENT

EXCELLENT

VERY SLIGHT

IGI LG818646006

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